



SUGHRUE MION, PLLC

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February 13, 2002

BOX PATENT APPLICATION  
Commissioner for Patents  
Washington, D.C. 20231

Re: Application of Jun SUNAGAWA, Yoshio BIZEN and Michihiro NAGAO  
METHOD FOR PRODUCING AMORPHOUS ALLOY RIBBON, AND METHOD  
FOR PRODUCING NANO-CRYSTALLINE ALLOY RIBBON WITH SAME  
Assignee: HITACHI METALS, LTD.  
Our Ref. Q68522

JC979 U.S. Pro  
10/07/3148  
02/13/02

Dear Sir:

Attached hereto is the application identified above comprising fifty (50) sheets of the specification, including the claims and abstract and , five (5) sheets of drawings. The executed Declaration and Power of Attorney and Assignment will be submitted at a later date.

The Government filing fee is calculated as follows:

Total claims	<u>10</u>	-	<u>20</u>	=	<u>      </u>	x	\$18.00	=	<u>      </u>	\$0.00	
Independent claims	<u>2</u>	-	<u>3</u>	=	<u>      </u>	x	\$84.00	=	<u>      </u>	\$0.00	
Base Fee											\$740.00
<b>TOTAL FEE</b>											<b>\$740.00</b>

A check for the statutory filing fee of \$740.00 is attached. You are also directed and authorized to charge or credit any difference or overpayment to Deposit Account No. 19-4880. The Commissioner is hereby authorized to charge any fees under 37 C.F.R. §§ 1.16 and 1.17 and any petitions for extension of time under 37 C.F.R. § 1.136 which may be required during the entire pendency of the application to Deposit Account No. 19-4880. A duplicate copy of this transmittal letter is attached.

Priority is claimed from:

<u>Country</u>	<u>Application No</u>	<u>Filing Date</u>
Japan	2001-36999	February 14, 2001

The priority document will be filed at a later date.

Respectfully submitted,  
SUGHRUE MION, PLLC

Attorneys for Applicant  
By:   
Peter D. Olexy  
Registration No. 24,513

PDO/amt